


APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	[IONIZED PHYSICAL VAPOR DEPOSITION PROCESS AND APPARATUS THEREOF]		
Application Type :		regular, utility	
Attorney Docket Number :		11439-US-PA	
Correspondence address:			
Customer Number:	31561		
Priority Data:			
Doc.No: 92118826; Country -TW ; Date: 2003-07-10 us-priority-claimed			
Inventor Information:			
<u>Inventor 1:</u>			
Applicant Authority Type:	Inventor		
Citizenship:	TW		
Name prefix:	Mr.		
Given Name:	WEN-PIN		
Family Name:	CHIU		
Residence:			
City of Residence:	YUNLIN COUNTY		
Country of Residence:	TW		
Address-1 of Mailing Address:	NO. 65, LIN 5, TIENTZU-LIN, DABI SHIANG		
Address-2 of Mailing Address:			
City of Mailing Address:	YUNLIN COUNTY		
State of Mailing Address:			
Postal Code of Mailing Address:			
Country of Mailing Address:	TW		
Phone:			
Fax:			
E-mail:			
Attorney Information:			
practitioner(s) at Customer Number:			

31561



as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.